

1753 #15
JL
03/20/03

PTO/SB/21 (08-00)

Approved for use through 10/31/2002. OMB 0651-0031
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|--|----------------------|------------------------|-----------|
| TRANSMITTAL FORM <i>(to be used for all correspondence after initial filing)</i> | Application Number | 10/002,397 | |
| | Filing Date | 10/31/2001 | |
| | First Named Inventor | Jian Ding | |
| | Group Art Unit | 1753 | |
| | Examiner Name | Unknown | |
| Total Number of Pages in This Submission | 4 | Attorney Docket Number | 306 MC 09 |

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| ENCLOSURES (check all that apply) | | |
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| <input type="checkbox"/> Fee Attached | <input type="checkbox"/> Drawing(s) | <input type="checkbox"/> Appeal Communication to Board of Appeals and Interferences |
| <input type="checkbox"/> Amendment / Reply | <input type="checkbox"/> Licensing-related Papers | <input type="checkbox"/> Appeal Communication to Group (Appeal Notice, Brief, Reply Brief) |
| <input type="checkbox"/> After Final | <input type="checkbox"/> Petition | <input type="checkbox"/> Proprietary Information |
| <input type="checkbox"/> Affidavits/declaration(s) | <input type="checkbox"/> Petition to Convert to a Provisional Application | <input type="checkbox"/> Status Letter |
| <input type="checkbox"/> Extension of Time Request | <input type="checkbox"/> Power of Attorney, Revocation Change of Correspondence Address | <input type="checkbox"/> Other Enclosure(s) (please identify below): |
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| <input type="checkbox"/> Certified Copy of Priority Document(s) | <input type="checkbox"/> CD, Number of CD(s) _____ | |
| <input type="checkbox"/> Response to Missing Parts/Incomplete Application | Remarks | |
| <input type="checkbox"/> Response to Missing Parts under 37 CFR 1.52 or 1.53 | | |

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| SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT | |
|--|-----------------------------------|
| Firm or Individual name | Robert M. Wallace Reg. No. 29,119 |
| Signature | <i>Robert M. Wallace</i> |
| Date | <i>Feb 21, 2003</i> |

| CERTIFICATE OF MAILING | |
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| I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231 on this date: 02-21-03 | |
| Typed or printed name | Shelly Hart |
| Signature | <i>Shelly Hart</i> |
| Date | <i>February 21, 2003</i> |

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PATENT

Attorney Docket No. 306 MC 09
RW Ref. No. APM/063-97-CPA-CN1



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Jian Ding

Entitled: LOW CEILING TEMPERATURE
PROCESS FOR A PLASMA REACTOR WITH
HEATED SOURCE OF A POLYMER-HARDENING
PRECURSOR MATERIAL

Serial No.: 10/002,397

Filing Date: October 31, 2001

)
) Group Art Unit: 1753

)
) Examiner: Unknown

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INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(b)

Commissioner for Patents
United States Patent & Trademark Office
Washington, D.C. 20231

Sir:

Attached hereto is Form PTO-1449 listing documents believed relevant to the subject application. It is respectfully requested that these documents be made of record and an initialed copy of each form be returned to the undersigned.

No representation is made that more pertinent material is not available or should not be considered by the Examiner. It is expected that the Patent and Trademark Office will independently conduct a complete search of appropriate art. Furthermore, no admission is being made that these documents are prior art, and applicant reserves the right to challenge any such consideration.

It is believed that this disclosure complies with the requirements of 37 CFR 1.56, 1.97, and 1.98, and the Manual of Patent Examining Procedures, section 609 and 707.05. If for some reason the Examiner considers otherwise, it is respectfully requested that the undersigned be called so that any deficiencies can be remedied.



A copy of each document is enclosed unless indicated otherwise. Some of the documents may have markings on them. No significance is meant to be attached to the markings. These documents are not necessarily analogous art.

Respectfully submitted,

Robert M. Wallace
Registration No. 29,119
Attorney for Applicants

Dated:

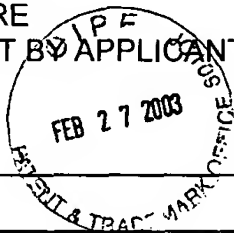
Feb 20 2003

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INFORMATION
DISCLOSURE
STATEMENT BY APPLICANT

Sheet 1 of 1



Application Number: 10/002,397
Filing Date: October 31, 2001
First Named Inventor: Jian Ding
Group Art Unit: 1753
Examiner Name: Unknown
Attorney Docket Number: 306 MC 09

U. S. PATENT DOCUMENTS

| Examiner Initials | Document No | Issue Date | Name of Patentee of Applicant of Cited Document | Class | Subclass | Filing Date |
|----------------------|-------------|------------|--|-------|----------|-------------|
| | 5,779,849 | 07-14-98 | BLALOCK | 156 | 345 | 01-30-97 |
| | 5,599,396 | 02-04-97 | SANDHU | 118 | 723 | 05-22-96 |
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FOREIGN PATENT DOCUMENTS

| Examiner Initials | Foreign Patent Document | Date | Country | Name | Translation? (Yes/No/n/a) |
|----------------------|----------------------------|------|---------|------|------------------------------|
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OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS

| Examiner Initials | |
|----------------------|--|
| | Wolf, Stanley Ph.D. and Tauber, Richard Ph.D., "SILICON PROCESSING FOR THE VLSI ERA," Vol. 1, <i>Process Technology</i> , California, 1986, pp. 568-572. |
| | |
| | |

Examiner's Signature:

Date Considered:

EXAMINER: Initial if reference considered, whether or not citation is in compliance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.